



JPL

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q79054

Masashi OTSUKI, et al.

Appln. No.: 10/758,130

Group Art Unit: 1754

Confirmation No.: 5017

Examiner: Ngocyen M Nguyen

Filed: January 16, 2004

For: SILICON CARBIDE POWDER AND METHOD FOR PRODUCING THE SAME

**PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of one month(s), extending the time for responding to the Office Action of October 5, 2004 to February 5, 2005.

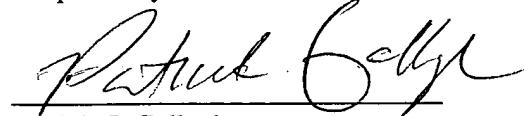
A check for the statutory fee of \$120.00 is attached. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this sheet is enclosed.

02/08/2005 SDENBOB1 00000016 10758130

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120.00 OP

Respectfully submitted,



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Date: February 7, 2005